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Image AF/1765

EXPEDITED PROCEDURE: GROUP 1765

Attorney's Docket No.: 10559-584001

Intel Docket No.: P12765



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Chris E. Barnes, et al

Art Unit : 1765

Serial No. : 10/008,683

Examiner : Duy Vu Nguyen Deo

Filed : December 4, 2001

Assignee : Intel Corporation

Title : POLYSILICON OPENING POLISH

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO FINAL OFFICE ACTION
OF NOVEMBER 19, 2003

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit

12/18/03

Signature

Till Bjorkman

Typed or Printed Name of Person Signing Certificate